



AF 1/11 IFW
cc

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

SHIOYA et al

Serial No.: 09/988,685

Filed: November 20, 2001

For: SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING
THE SAME

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) Group Art Unit: 2813
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) Examiner: David Hogan
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RESPONSE TO FINAL ACTION UNDER 37 CFR 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the "final" action of April 5, 2004, please amend the captioned application as follows: